



N 09/858337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	William J. Schaff et al.	Examiner:	Khanh B Duong
Serial No.:	09/858337	Group Art Unit:	Unknown
Filed:	May 15, 2001	Docket No.:	1153.044US1
Title:	AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING		

12/c Andd
9.11.03
A. Wall

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant has reviewed the Office Action mailed on May 8, 2003. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a 1-month extension of the period for responding to the Office action, thereby moving the deadline for response from August 8, 2003 to September 8, 2003.

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